



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention	ATOMIC LAYER DEPOSITION APPARATUS						
Application Number:	09/917842					1 0000 0000 1000 1 0000 0000 1000 1000 0000 1000 1000	
Confirmation Number:	3573						
First Named Applicant:	Barry Chin						
Attorney Docket Number:	5017Y01						
Art Unit:	3573						
Examiner:	Alexander Kosowski						
Search string:	(6630030 or 6579372 or 6578287 or 6572705 or 6551406 or 6511539 or 6481945 or 6478872 or 6447607 or 6306216 or 6305314 or 6270572 or 6231672 or 6200893 or 6197683 or 6183563 or 6174377 or 6139700 or 6042652 or 6015590 or 5916365 or 5879459 or 5855680 or 5835677 or 5807792 or 5796116 or 5730802 or 5711811 or 5674786 or 5503875 or 5483919 or 5480818 or 5443647 or 5441703 or 5374570 or 5338362 or 5294286 or 5281274 or 5261959 or 5225366 or 4993357 or 4975252 or 4834831 or 4413022 or 4389973 or 4058430).pn.						
<div>RECEIVED FEB 18 2004 Technology Center 2100</div>							
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
<input checked="" type="checkbox"/>	1	6630030	2003-10-07	Suntola et al.	B1		
<input checked="" type="checkbox"/>	2	6579372	2003-06-17	Park	B2		
<input checked="" type="checkbox"/>	3	6578287	2003-06-17	Aswad	B2		
<input checked="" type="checkbox"/>	4	6572705	2003-06-03	Suntola et al.			
<input checked="" type="checkbox"/>	5	6551406	2003-04-22	Kilpi			
<input checked="" type="checkbox"/>	6	6511539	2003-01-28	Raaijmakers			
<input checked="" type="checkbox"/>	7	6481945	2002-11-19	Hasper et al.			
<input checked="" type="checkbox"/>	8	6478872	2002-11-12	Chae et al.			
<input checked="" type="checkbox"/>	9	6447607	2002-09-10	Soininen et al.			
<input checked="" type="checkbox"/>	10	6306216	2002-10-23	Kim et al.			

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